

Docket No.: 4425-320

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:
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Chien-Hsin LAI <i>et al.</i>	: Confirmation No. 3535
	:
U.S. Patent Application No. 10/659,258	: Group Art Unit: 1763
	:
Filed: September 11, 2003	: Examiner: Karla A Moore

For: PLASMA APPARATUS AND METHOD CAPABLE OF ADAPTIVE IMPEDANCE
MATCHING

SUPPLEMENTAL RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Remarks are in furtherance of the Amendment filed August 18, 2006 in response to the Office Action of May 18, 2006.